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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/567,369	05/15/2006	Noboru Ichinose	PKHF-04053US	9867
	7590 08/19/200 ELLECTUAL PROPEI	EXAMINER		
8321 OLD COURTHOUSE ROAD			SALERNO, SARAH KATE	
SUITE 200 VIENNA, VA 2	SUITE 200 VIENNA, VA 22182-3817		ART UNIT	PAPER NUMBER
			2814	
			MAIL DATE	DELIVERY MODE
			08/19/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)			
	10/567,369	ICHINOSE ET AL.			
Office Action Summary	Examiner	Art Unit			
	SARAH K. SALERNO	2814			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim vill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).			
Status					
Responsive to communication(s) filed on 15 Ma This action is FINAL . 2b) ☑ This Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. nce except for formal matters, pro				
Disposition of Claims					
4) ☐ Claim(s) 1-8 is/are pending in the application. 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-8 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or Application Papers 9) ☐ The specification is objected to by the Examine 10) ☐ The drawing(s) filed on is/are: a) ☐ access Applicant may not request that any objection to the orecast that any objection the orecast that the orecast the orecast the orecast the orecast the orec	r election requirement. r. epted or b)⊡ objected to by the B drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).			
11) The oath or declaration is objected to by the Ex					
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 2/7/06.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	nte			

Application/Control Number: 10/567,369 Page 2

Art Unit: 2814

DETAILED ACTION

Specification

1. The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States
- 3. Claims 1-8 are rejected under 35 U.S.C. 102(b) as being anticipated by Udagawa (JP 2000-349336).
 - Claim 1: Udagawa teaches a semiconductor layer, characterized by comprising: a first layer made of a Ga₂O₃ system semiconductor (102); and a second layer (103) obtained by replacing a part or all of oxygen atoms of the
- first layer with nitrogen atoms [0023-0026].
- Claim 2: Udagawa teaches the second layer is made of a GaN system compound semiconductor [0026]
- Claim 3: Udagawa teaches the first layer is a Ga₂O₃ system single crystal substrate [0021].

Application/Control Number: 10/567,369 Page 3

Art Unit: 2814

Claim 4: Udagawa teaches the first layer is made of Ga_2O_3 , $(In_xGa_{l-x})_2O_3$ where $0 \le x < I$, $(Al_xGa_{l-x})_2O_3$ where $0 \le x < I$, $(In_xAl_yGa_{1-x-y})_2O_3$ where $0 \le x < I$, $0 \le y < I$, and $0 \le x + y < I$, or the like, as a main constituent [0025].

Claim 5: Udagawa teaches the second layer is made of GaN, $In_zGa_{1-z}N$ where 0 \leq z < 1, $Al_zGa_{1-z}N$ where 0 \leq z < 1, $In_zAl_pGa_{1-z-p}N$ where 0 \leq z < 1, 0 \leq p < 1, and 0 \leq z + p < 1, or the like, as a main constituent [0027].

Claim 6: Udagawa teaches a semiconductor layer, characterized by comprising: a first layer made of a Ga₂O₃ system semiconductor;

a second layer made of a GaN system compound semiconductor and obtained by replacing a part or all of 6 oxygen atoms of the first layer with nitrogen atoms; and a third layer made of an GaN system epitaxial layer and formed on the second layer [0023-0027].

Claim 7: Udagawa teaches a semiconductor layer, characterized by comprising: a first layer made of a Ga_2O_3 system semiconductor; and

a second layer made of a GaN system compound semiconductor and formed on the first layer [0023-0026].

Claim 8: Udagawa teaches a semiconductor layer, characterized by comprising: a first layer made of a Ga₂O₃ system semiconductor;

a second layer made of a GaN system compound semiconductor and formed on the first layer; and

a third layer made of an GaN system epitaxial layer and formed on the second layer [0023-0027].

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. "Preparation and structural properties for GaN films grown on Si (111) by annealing" by Yang et al. (IDS reference) reads on claims 1,2,4,5 & 7.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to SARAH K. SALERNO whose telephone number is (571)270-1266. The examiner can normally be reached on M-F 8:00-4:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (571) 272-1705. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/S. K. S./ Examiner, Art Unit 2814

/Theresa T. Doan/ Primary Examiner, Art Unit 2814 Application/Control Number: 10/567,369

Page 5

Art Unit: 2814